



PATENT
Customer No. 22,852
Attorney Docket No. 03180.0278

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ryoichi INANAMI et al.

Application No.: 09/817,270

Filed: March 27, 2001

For: EXPOSURE PATTERN DATA
GENERATION APPARATUS
ASSOCIATED WITH STANDARD
CELL LIBRARY AND CHARGED
BEAM EXPOSURE

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) Group Art Unit: 2881
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) Examiner: Phillip A. Johnston
)
)
) Confirmation No.: 7690
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Mail Stop RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

This Amendment is being filed along with a Request for Continued Examination (RCE) and fulfills the requirement for a submission under 37 C.F.R. § 1.114. In reply to the Office Action mailed June 2, 2005, the period for response having been extended through November 2, 2005 by a request for an extension of two months and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper beginning on page 2.

Remarks/Arguments follow the amendment sections of this paper beginning on page 17.